AMENDMENTS TO THE CLAIMS

1. (Currently amended) A process for depositing a metal structure on a surface of a

workpiece defining a plurality of recessed microstructures, comprising:

(a) exposing the surface of the workpiece to an electroplating bath including a

source of metal ions to be deposited on the surface and an organic additive that influences the

metal ions to be preferentially deposited within the recessed microstructures relative to a

surrounding surface, the recessed microstructures including a sidewall, bottom surface and an

opening opposite the bottom surface, wherein the organic additive comprises an accelerator

agent;

(b) supplying net forward electroplating power between the surface of the

workpiece and an anode disposed in electrical contact with the electroplating bath for a first time

period, the first time period and a level of forward electroplating power supplied during the first

time period are selected such that metal ions are deposited within the recessed microstructures to

at least partially fill the recessed microstructures during the first time period; and

(c) reversing the electroplating power supplied between the anode and the

surface of the workpiece for at least a portion of a second time period, the second time period

being greater than or equal to ten seconds, the second time period and a level of reverse

electroplating power supplied during the second time period are selected to limit deposition of an

overburden of metal ions over the at least partially filled recessed microstructures relative to the

surrounding surface.

(Canceled)

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 (Previously presented) The process of Claim 1, wherein during the second time period the power that is supplied between the anode and the surface of the workpiece is

alternated between pulses of forward power interspersed with pulses of reverse power.

4. (Original) The process of Claim 3, wherein the duration of each pulse of reverse

power is greater than 1 millisecond.

5. (Original) The process of Claim 4, wherein the duration of each pulse of reverse

power is greater than or equal to 10 milliseconds.

6. (Canceled)

7. (Previously presented) The process of Claim 3 wherein the second time period is

greater than or equal to 60 seconds.

8. (Previously presented) The process of Claim 1, wherein the reverse electroplating

power is sustained for the duration of the second time period, and further comprising supplying

electroplating power between the surface of the workpiece and the anode for a third time period before or after the second time period during which third time period forward and reverse

electroplating power is supplied in a series of interspersed pulses.

9-10. (Canceled)

11. (Original) The process of Claim 1, wherein the reverse electroplating power is

supplied at a reverse current of absolute magnitude greater than 1 amp.

12. (Original) The process of Claim 1, wherein the reverse electroplating power is

supplied at a voltage potential of absolute magnitude greater than 0.05 volts.

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Suite 2800 Seattle, Washington 98101 206.682.8100 (Original) The process of Claim 1, wherein the metal that is deposited comprises copper.

copper.

14. (Original) The process of Claim 13, wherein the source of metal ions comprises

copper sulfate.

15. (Currently amended) The process of Claim 14, wherein the electroplating bath

further comprises a source of ehlorine chloride ions.

16. (Canceled)

17. (Currently amended) The process of Claim 1, wherein the accelerator

agent includes the chemical structure S-R₁-S, wherein R₁ comprises an alkyl or an aryl group.

18. (Original) The process of Claim 1, wherein the organic additive comprises a

suppressor agent.

19. (Original) The process of Claim 18, wherein the suppressor agent comprises a

compound including the chemical structure N-R $_1$ -S, wherein R $_1$ comprises an alkyl or an aryl

group.

20. (Original) The process of Claim 1, wherein the organic additive comprises a

leveler agent.

21. (Original) The process of Claim 20, wherein the leveler agent comprises a

polyethylene glycol or polyoxyethylene glycol.

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1420 Fifth Avenue Suite 2800 Seattle, Washington 98101 206.682.8100 22. (Original) The process of Claim 1, further comprising supplying forward electroplating power between the surface of the workpiece and the anode for a third time period after the second time period.

(Canceled)

- (Currently amended) A process for depositing a metal structure on a surface of a workpiece defining a plurality of recessed microstructures, comprising:
- (a) exposing the surface of the workpiece to an electroplating bath including a source of metal ions to be deposited on the surface and an organic additive that is absorbed adsorbed on the surface and influences the metal ions to be preferentially deposited within the recessed microstructures relative to the remainder of the surface, the recessed microstructures including a sidewall, bottom surface and an opening opposite the bottom surface, wherein the organic additive comprises an accelerator agent;
- (b) supplying net forward electroplating power between the surface of the workpiece and an anode disposed in electrical contact with the electroplating bath for a first time period and at a first level of supplied power selected so that metal ions are deposited to at least partially fill the recessed microstructures; and
- (c) reversing the electroplating power supplied between the anode and the surface of the workpiece during at least a portion of a second time period that is greater than or equal to ten seconds, the second time period and a second level of applied power selected to limit the deposition of further metal ions over the at least partially filled recessed microstructures relative to the remainder of the surface and to desorb the organic additives to limit the development of an overburden of metal over the at least partially filled recessed microstructures.

 (Currently amended) A process for depositing a metal structure on a surface of a workpiece defining a plurality of recessed microstructures, comprising:

(a) exposing the surface of the workpiece to an electroplating bath including a

source of metal ions to be deposited on the surface and an accelerator agent;

(b) supplying net forward electroplating power between the surface of the

workpiece and an anode disposed in electrical contact with the electroplating bath for a first

period of time and under a first set of plating process parameters such that metal ions are

preferentially deposited within the recessed microstructures relative to the remainder of the

surface to at least partially fill the recessed microstructures during the first time period, the

recessed microstructures including a sidewall, bottom surface and an opening opposite the

bottom surface; and

(c) supplying electroplating power between the anode and the surface of the

workpiece during a second time period in a series of forward plating power pulses interspersed

with reverse plating power pulses to limit the deposition of further metal ions over the at least partially filled recessed microstructures relative to the remainder of the surface, the second time

period being greater than or equal to ten seconds.

26. (Currently amended) A process for depositing a metal structure on a surface of a

workpiece defining a plurality of recessed microstructures, comprising:

(a) exposing the surface of the workpiece to an electroplating bath including a

source of copper ions, an acid, a source of ehlorine chloride ions and an organic additive that

influences copper ions to be preferentially deposited within the recessed microstructures relative

to the remainder of the surface, the recessed microstructures including a sidewall, bottom surface

and an opening opposite the bottom surface, wherein the organic additive comprises an

accelerator agent;

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(b) supplying net forward electroplating power between the surface of the

workpiece and an anode disposed in electrical contact with the electroplating bath for a first period of time and at a first level of supplied power such that copper ions are preferentially

deposited within the recessed microstructures relative to the remainder of the surface to at least

partially fill the recessed microstructures during the first period of time; and

(c) supplying electroplating power between the anode and the surface of the

workpiece during a second time period in a series of forward plating power pulses interspersed

with reverse plating power pulses to limit the deposition of further copper ions over the at least

partially filled recessed microstructures relative to the remainder of the surface, the second time

period being greater than or equal to ten seconds.

(Canceled)

28. (Currently amended) An electroplating apparatus for applying a metal structure

to a surface of a workpiece defining a plurality of recessed microstructures, comprising:

(a) a reactor for receiving the surface of the workpiece and exposing the

surface to an electroplating bath including a source of metal ions and an organic additive that

influences the metal ions to be preferentially deposited within the recessed microstructures relative to the remainder of the surface, wherein the organic additive comprises an accelerator

agent;

(b) an anode in electrical contact with the electroplating bath;

(c) a power supply for supplying electroplating power between the surface of

the workpiece and the anode to electroplate the metal ions onto the surface, the power supply

being capable of supplying forward power and reverse power; and

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(d) a controller for controlling the power supply to supply a level of net forward electroplating power during the first time period so that the metal ions are deposited within the recessed microstructures to at least partially fill the recessed microstructures during the first time period and to supply a level of reverse electroplating power for at least a portion of

a second time period to limit the deposition of further metal ions over the at least partially filled

recessed microstructures relative to the remainder of the surface, the second time period being

greater than or equal to ten seconds.

29. (Previously presented) The apparatus of Claim 28, wherein the controller is

operable to control the power supply during the second time period so that the power that is

supplied between the anode and the surface of the workpiece is alternated between pulses of

forward plating power interspersed with pulses of reverse plating power.

30. (Previously presented) The apparatus of Claim 28, wherein the controller is

operable to control the power supply to supply sustained reverse electroplating power for the

duration of the second time period, wherein the controller is further operable to control the power

supply to supply electroplating power between the surface of the workpiece and the anode for a

third time period during which forward and reverse electroplating power is supplied in a series of

interspersed pulses.

31. (Previously presented) The apparatus of Claim 28, wherein the controller is

operable to control the power supply to supply forward electroplating power between the surface

of the workpiece and the anode for a third time period after the second time period.

32. (Previously presented) The process of Claim 1, wherein during the first time

period, metal ions are deposited on the surface and within the recessed microstructures.

LAW OFFICES OF CHRISTENSEN O'CONNOR JOHNSON KINDNESS'** 1420 Fifth Avenue Suite 2800 Seattle, Washington 98101 206.682 8100 33. (Previously presented) The process of Claim 3, further comprising periods of off

power between the pulses of forward power and the pulses of reverse power.

34. (Previously presented) The process of Claim 25, further comprising periods of

off power between the forward plating power pulses and the reverse plating power pulses.

35. (Previously presented) The process of Claim 24, wherein reversing the

electroplating power supplied between the anode and the surface of the workpiece during at least

a portion of a second time period is provided by alternating pulses of forward power interspersed

with pulses of reverse power with periods of off power between the pulses of forward power and

the pulses of reverse power.

36. (Previously presented) The process of Claim 26, further comprising periods of

off power between the forward plating power pulses and the reverse plating power pulses.

37. (Previously presented) The apparatus of Claim 29, wherein the controller is

operable to control the power supply so that periods of off power exist between the pulses of

forward plating power and the pulses of reverse plating power.

38. (Previously presented) The apparatus of Claim 29, further comprising a diffuser

plate between an anode and a location of the workpiece when the workpiece is received by the

reactor.

39. (New) The process of Claim 1, wherein the reverse electroplating power is

supplied at a reverse current density of absolute magnitude greater than about 3 mA/cm².

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